

JUL 25 2006

Attorney's Docket No.: 004711/P1  
Confirmation No.: 4749Patent

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Steven Verhaverbeke, et al.

Application No: 09/891,849

Filed: June 25, 2001

For: METHOD AND APPARATUS  
FOR WAFER CLEANING

Examiner: Markoff, Alexander

Art Unit: 1746

Mail Stop Amendment  
Commissioner For Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450AMENDMENT AND RESPONSE TO OFFICE ACTION

Dear Sir:

In response to the Office Action dated March 22, 2006, Applicant respectfully requests that the above-identified application be amended as follows and that the following remarks be considered:

CERTIFICATE OF MAILING/TRANSMISSION (37 CFR 1.8A)

I hereby certify that this correspondence is being transmitted by facsimile on the date shown below to the United States Patent and Trademark Office:

July 24 2006

Date of Transmission

Neal Berezny

Name of Person Transmitting Correspondence



Signature

July 24 2006

Date

Application No.: 09/891,849  
Filing Date: June 25, 2001

- 1/23 -

AMAT Ref. No.: 004711USAPY1/W-C/W-C/  
BSTZ Ref. No.: 004887.P454X